

Application/Control No.	Applicant(s)/Patent under Reexamination
09/966,419	VANDENAMEELE-LEPLA, PATRICK
Examiner	Art Unit
Hong Cho	2662

SEARCHED						
Class	Subclass	Date	Examiner			
370	206-208, 482	10/28/2005	нс			
375	152, 260	10/28/2005	НС			
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
370	206, 482	10/28/2005	нс		
375	152, 260	10/28/2005	нс		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
DATE	EXMR			
8/29/2005	нс			
10/28/2005	нс			
11/9/2005	нс			
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	DATE 8/29/2005 10/28/2005			